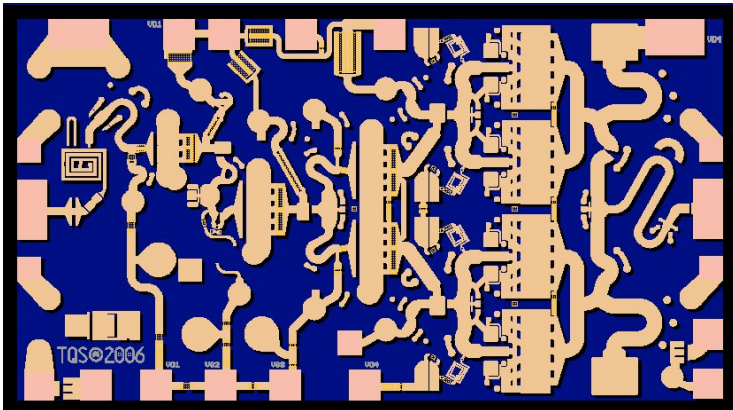


**12 - 16 GHz High Linearity Amplifier**

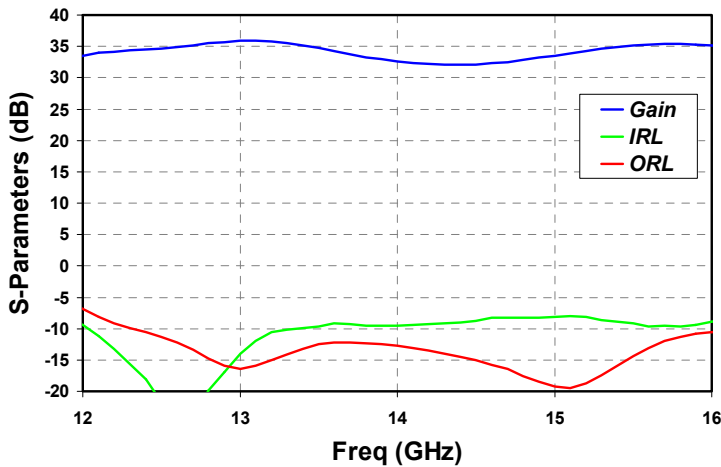


**Key Features and Performance**

- 31 dBm Midband Pout
- 33 dB Nominal Gain
- TOI > 40 dBm
- 0.5 μm pHEMT 3MI Technology
- Bias Conditions: 6 V, 850mA
- Chip dimensions: 2.5 x 1.4 x 0.1 mm (98 x 55 x 4 mils)

**Preliminary Measured Data**

Bias Conditions: Vd=6 V Id=850 mA



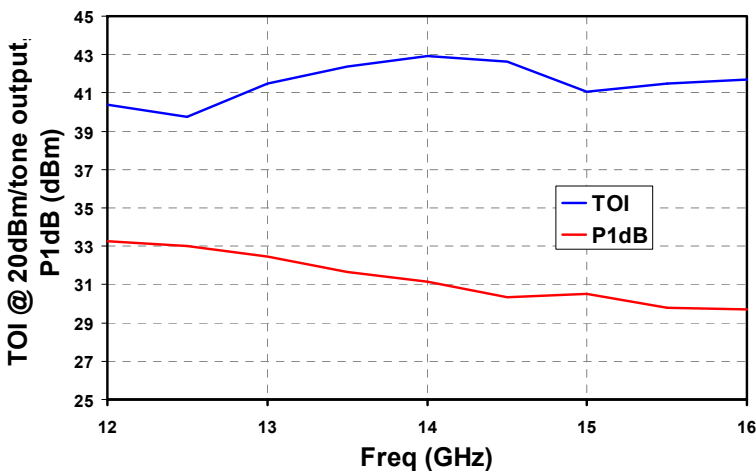
**Primary Applications**

- Point-to-Point Radio
- VSAT
- Ku Band Sat-Com

**Product Description**

The TriQuint TGA2520 MMIC is an extremely linear, high gain amplifier, capable of 1 Watt output power at P1dB for the frequency range of 12 – 16 GHz. This performance makes this amplifier ideally suited for Point to Point Radios and current Ku-Band satellite ground terminal applications. The TGA2520 utilizes TriQuint’s robust 0.5um power pHEMT process coupled with 3 layer Metal Inteconnect (3MI) technology. The TGA2520 provides the high power transmit function in an extremely compact (< 3.5mm<sup>2</sup>) chip footprint.

The combination of a high-yield process, electrical performance, and compact die size is exactly what is required to support the aggressive pricing targets required for low-cost transmit modules. Each device is 100% DC and RF tested on-wafer to ensure performance compliance. The device is available in chip form.



Datasheet subject to change without notice

**TABLE I  
MAXIMUM RATINGS**

<b>Symbol</b>	<b>Parameter <u>1/</u></b>	<b>Value</b>	<b>Notes</b>
V <sup>+</sup>	Positive Supply Voltage	8 V	<u>2/</u>
V <sup>-</sup>	Negative Supply Voltage Range	-5V to 0V	
I <sup>+</sup>	Positive Supply Current (under RF Drive)	1300 mA	<u>2/</u>
I <sub>G</sub>	Gate Supply Current Range	-7 to 56 mA	
P <sub>IN</sub>	Input Continuous Wave Power	23.2 dBm	<u>2/</u>
P <sub>D</sub>	Power Dissipation	9.8 W	<u>2/ 3/</u>
T <sub>CH</sub>	Operating Channel Temperature	200 °C	<u>3/ 4/ 5/</u>
	Mounting Temperature (30 Seconds)	320 °C	
T <sub>STG</sub>	Storage Temperature	-65 to 150 °C	

- 1/ These ratings represent the maximum operable values for this device.
- 2/ Combinations of supply voltage, supply current, input power, and output power shall not exceed P<sub>D</sub>.
- 3/ When operated at this bias condition with a base plate temperature of 70°C the median life is 2.3E4.
- 4/ These ratings apply to each individual FET.
- 5/ Junction operating temperature will directly affect the device median time to failure (T<sub>m</sub>). For maximum life, it is recommended that junction temperatures be maintained at the lowest possible levels.

**TABLE II**  
**RF CHARACTERIZATION TABLE**  
**(T<sub>A</sub> = 25°C, Nominal)**  
**(V<sub>d</sub> = 6 V, I<sub>d</sub> = 850mA ± 5%)**

SYMBOL	PARAMETER	TEST CONDITION	LIMITS			UNITS
			MIN	TYP	MAX	
Gain	Small Signal Gain	F = 12-16		33		dB
IRL	Input Return Loss	F = 12-16		8		dB
ORL	Output Return Loss	F = 12-16		12		dB
PWR	Output Power @ Pin = +5 dBm	F = 12-16		31		dBm

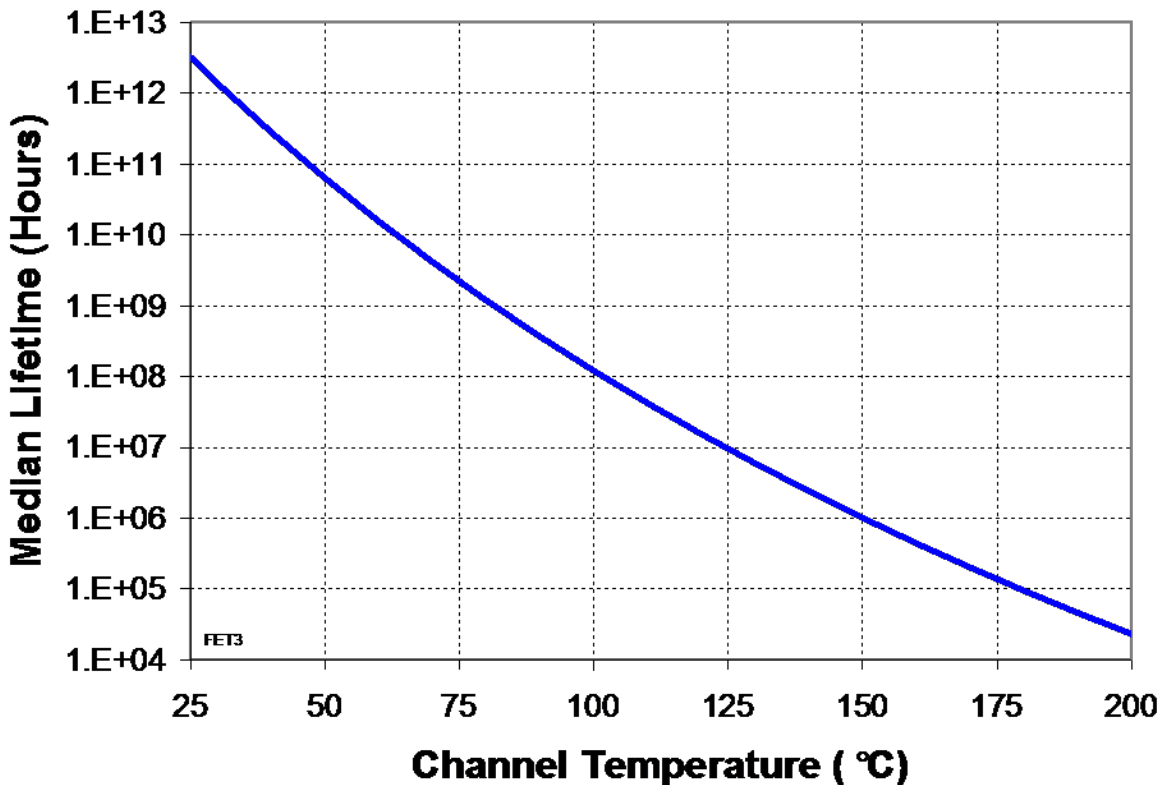
Note: Table II Lists the RF Characteristics of typical devices as determined by fixtured measurements.

**TABLE III  
THERMAL INFORMATION**

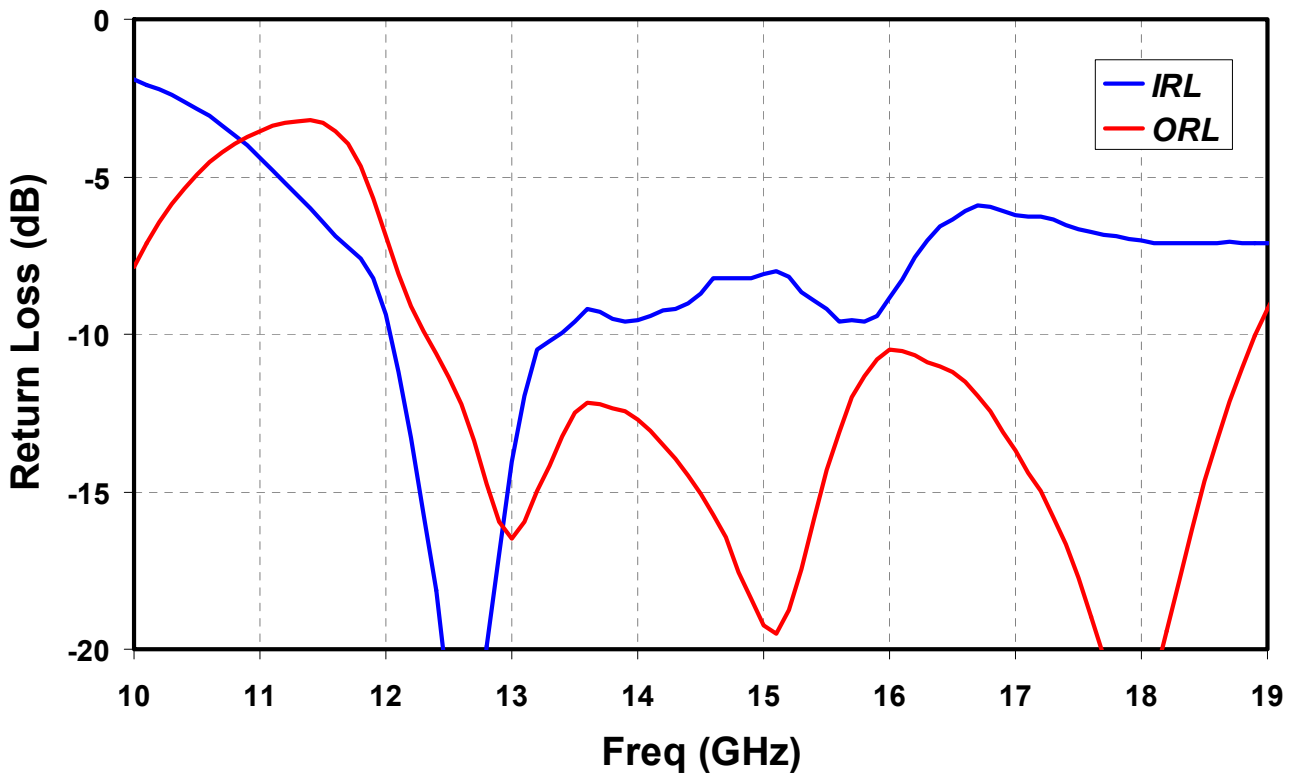
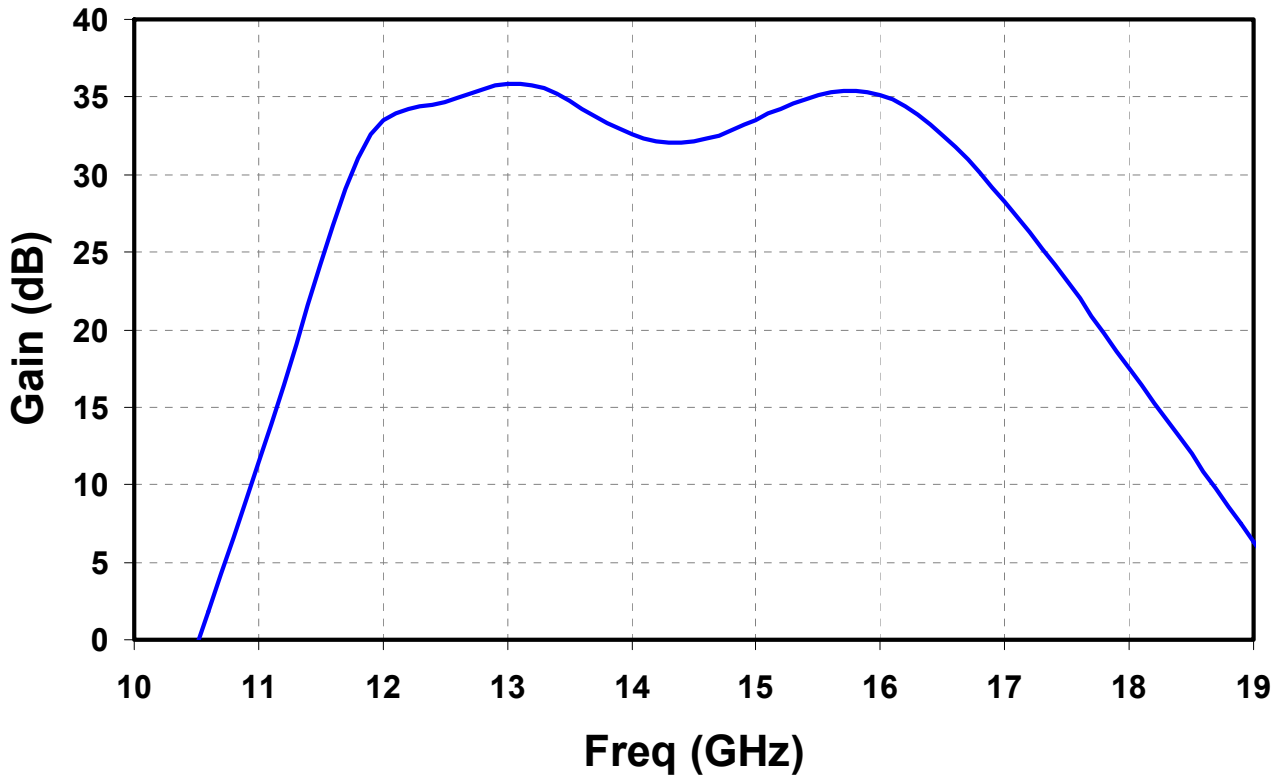
PARAMETER	TEST CONDITION	T <sub>CH</sub> (°C)	θ <sub>JC</sub> (°C/W)	T <sub>m</sub> (HRS)
θ <sub>JC</sub> Thermal Resistance (Channel to Backside)	V <sub>D</sub> = 6 V I <sub>D</sub> = 850 mA P <sub>D</sub> = 5.1 W	138	13.33	2.9 E+6
θ <sub>JC</sub> Thermal Resistance (Channel to Backside)	V <sub>d</sub> = 6V I <sub>d</sub> = 1200 mA (under drive) P <sub>diss</sub> = 6 W P <sub>out</sub> = 1.2 W (RF)	150	13.33	1.0 E+6

Note: Assumes eutectic attach using 1.5mil 80/20 AuSn mounted to a 20mil CuMo carrier at 70°C baseplate temperature. Worst case condition with no RF applied, 100% of DC power is dissipated.

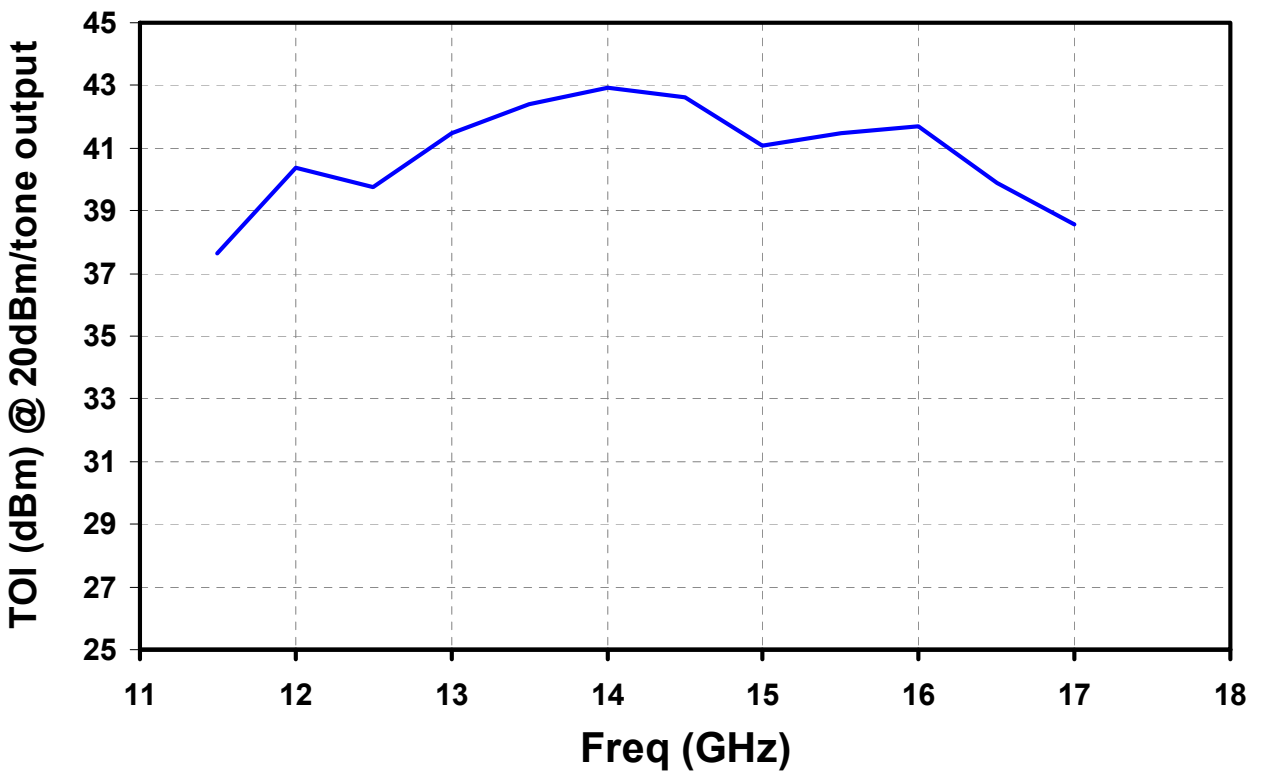
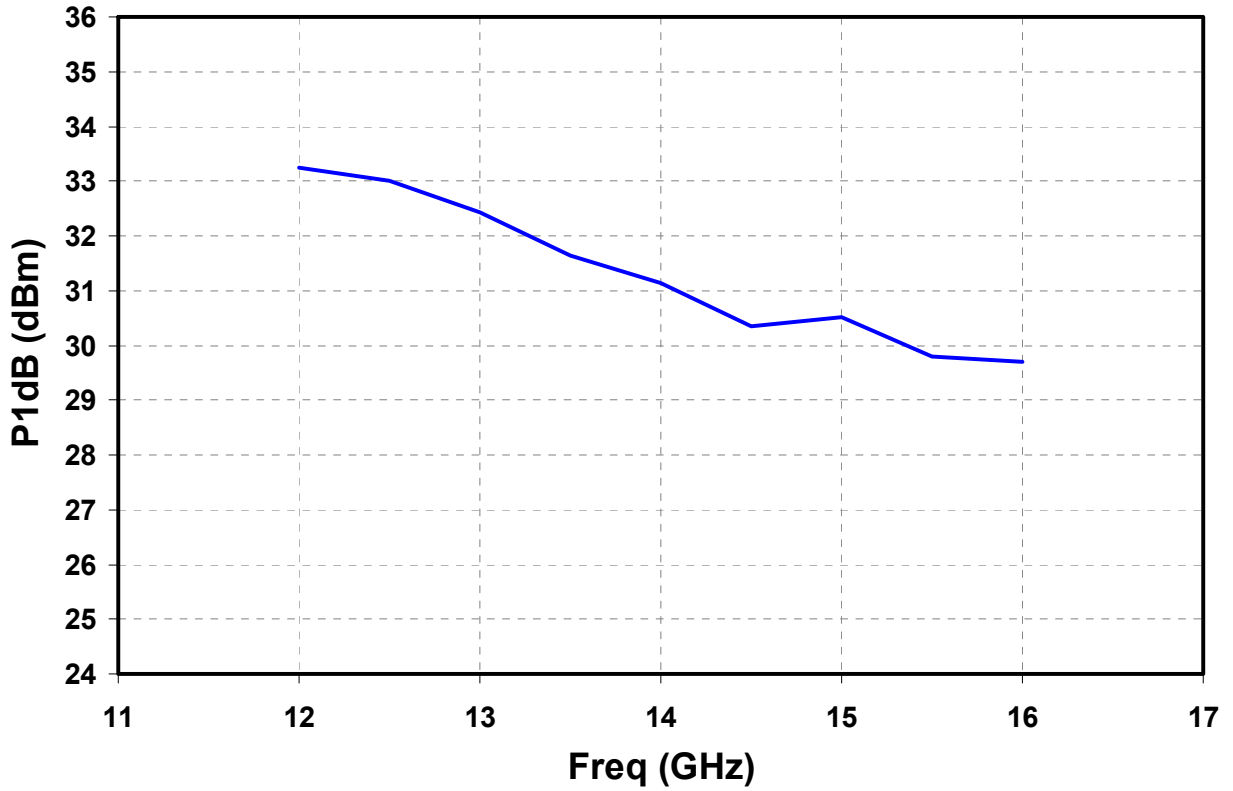
**Median Lifetime (T<sub>m</sub>) vs. Channel Temperature**



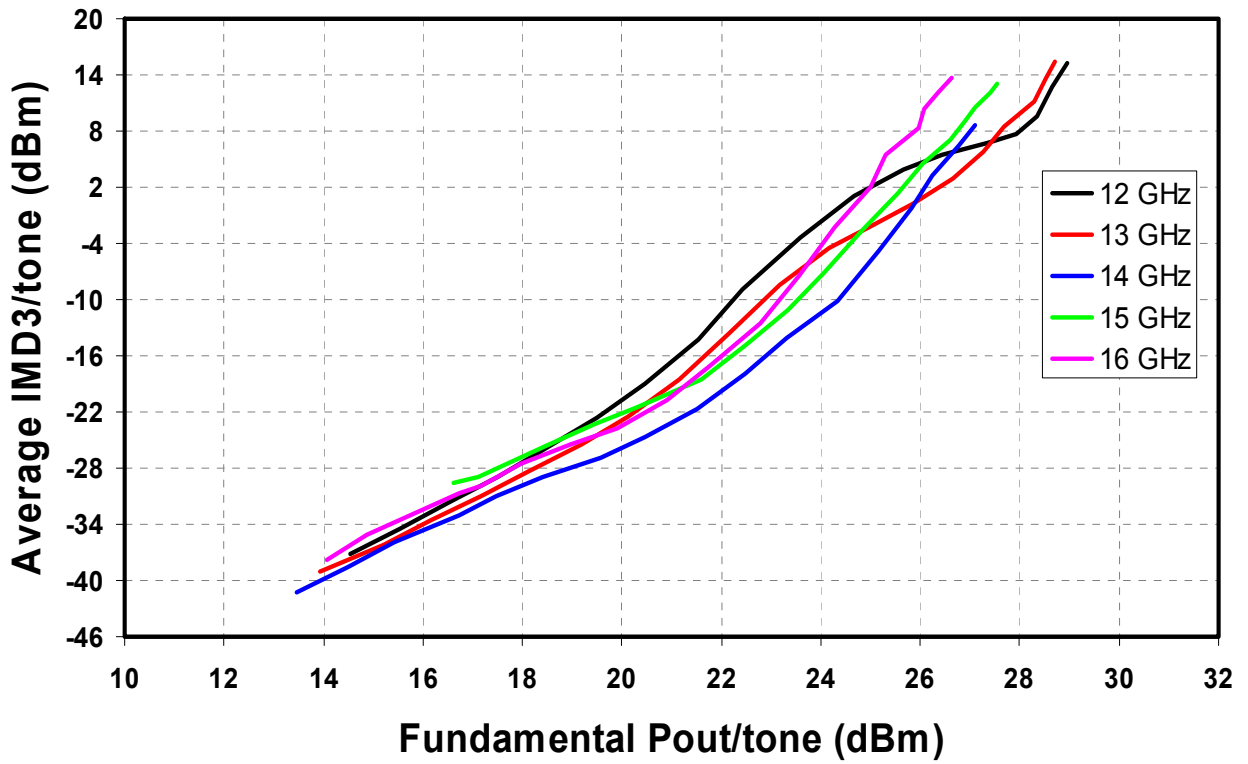
**Typical Fixtured Performance**



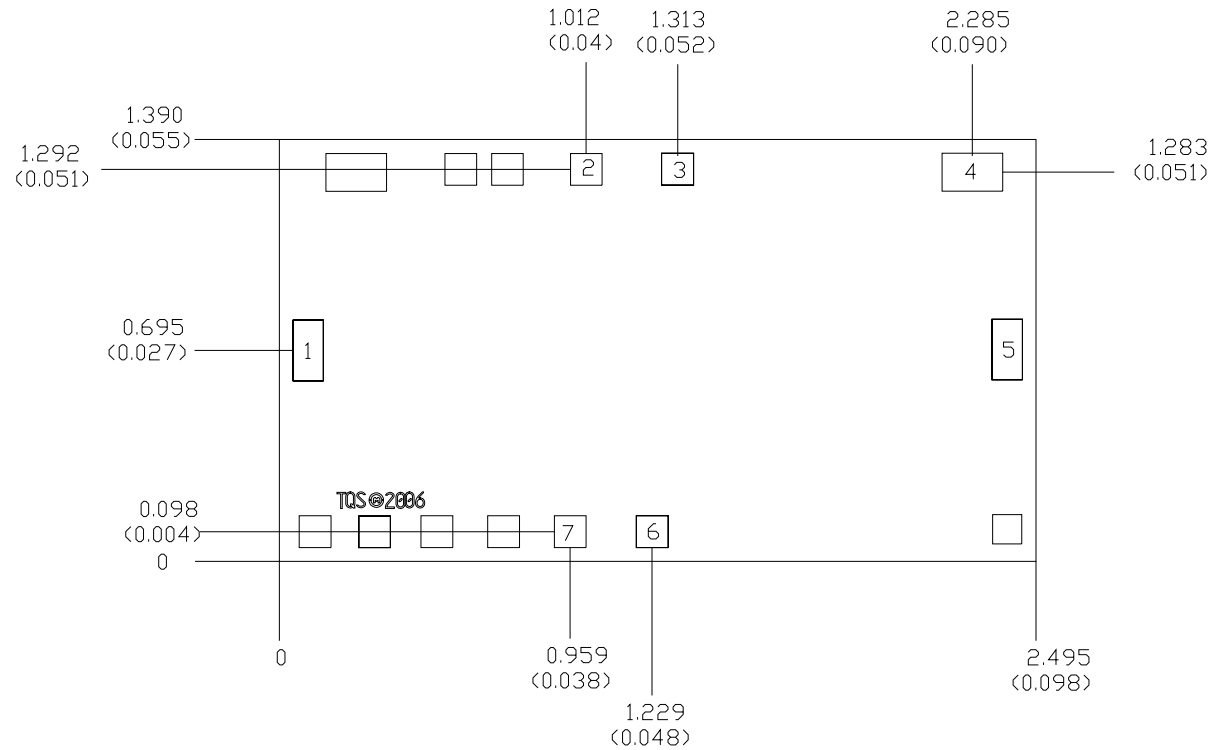
**Typical Fixtured Performance**



**Typical Fixtured Performance**



**Mechanical Drawing**



Units: millimeters (inches)

Thickness: 0.1016 (0.004) (reference only)

Chip edge to bond pad dimensions are shown to center of Bond pads.

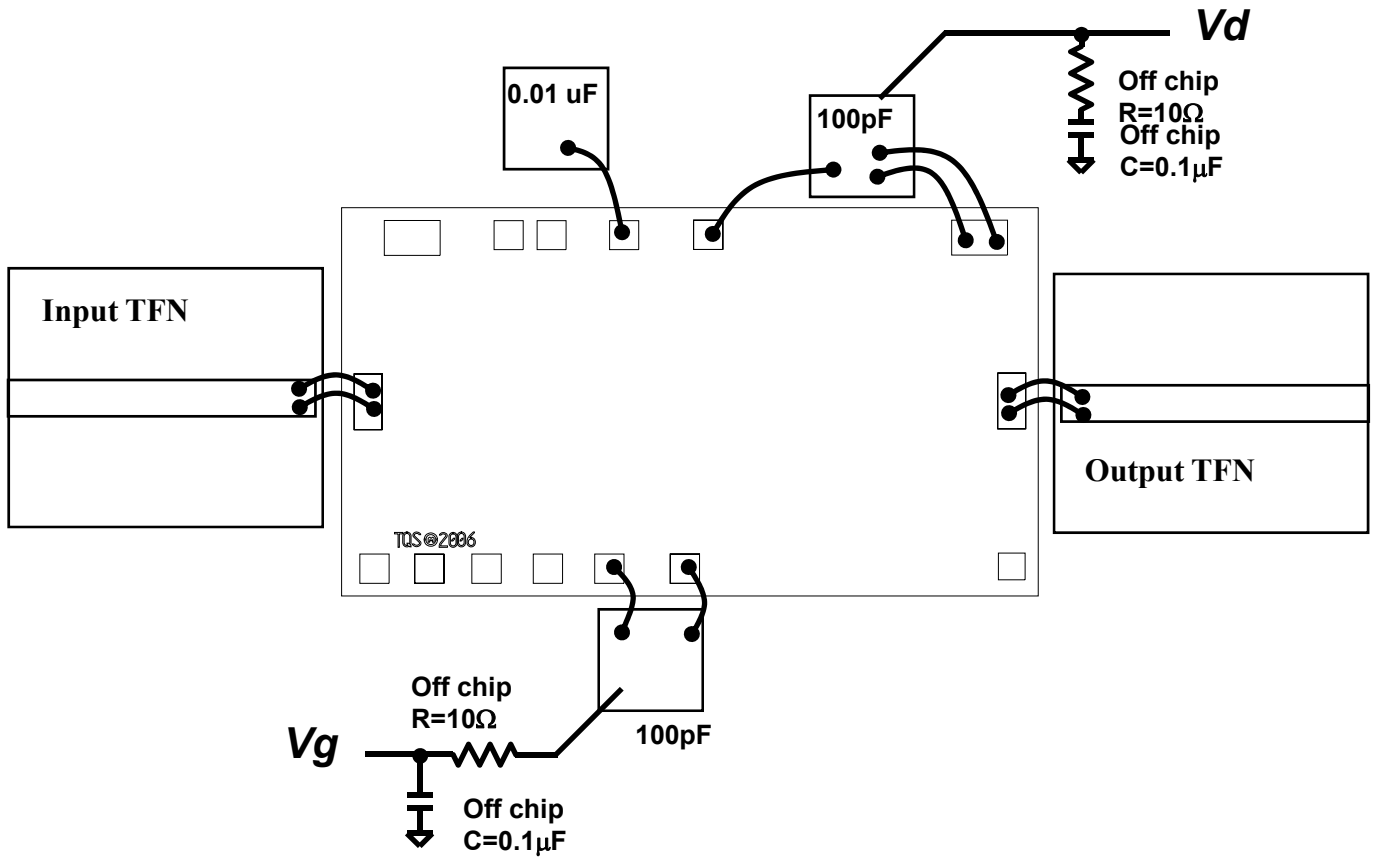
Chip size tolerance: +/- 0.0508 (0.002)

RF Ground through Backside

Bond Pad #1	(RF Input)	0.100 × 0.200	(0.004 × 0.008)
Bond Pad #2	(Bypass)	0.100 × 0.100	(0.004 × 0.004)
Bond Pad #3	(Vd1)	0.100 × 0.100	(0.004 × 0.004)
Bond Pad #4	(Vd2)	0.200 × 0.125	(0.008 × 0.005)
Bond Pad #5	(RF Output)	0.100 × 0.200	(0.004 × 0.008)
Bond Pad #6	(Vg2)	0.100 × 0.100	(0.004 × 0.004)
Bond Pad #7	(Vg1)	0.100 × 0.100	(0.004 × 0.004)



**Chip Assembly & Bonding Diagram**



**Typical  $V_g \approx -0.5 \text{ V}$**

*GaAs MMIC devices are susceptible to damage from Electrostatic Discharge. Proper precautions should be observed during handling, assembly and test.*

## Assembly Process Notes

Reflow process assembly notes:

- Use AuSn (80/20) solder with limited exposure to temperatures at or above 300°C. (30 seconds maximum)
- An alloy station or conveyor furnace with reducing atmosphere should be used.
- No fluxes should be utilized.
- Coefficient of thermal expansion matching is critical for long-term reliability.
- Devices must be stored in a dry nitrogen atmosphere.

Component placement and adhesive attachment assembly notes:

- Vacuum pencils and/or vacuum collets are the preferred method of pick up.
- Air bridges must be avoided during placement.
- The force impact is critical during auto placement.
- Organic attachment can be used in low-power applications.
- Curing should be done in a convection oven; proper exhaust is a safety concern.
- Microwave or radiant curing should not be used because of differential heating.
- Coefficient of thermal expansion matching is critical.

Interconnect process assembly notes:

- Thermosonic ball bonding is the preferred interconnect technique.
- Force, time, and ultrasonics are critical parameters.
- Aluminum wire should not be used.
- Discrete FET devices with small pad sizes should be bonded with 0.0007-inch wire.
- Maximum stage temperature is 200°C.

***GaAs MMIC devices are susceptible to damage from Electrostatic Discharge. Proper precautions should be observed during handling, assembly and test.***